

Docket No.: 060188-0793



PATENT

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Michikazu MATSUMOTO

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE**

Application No.: 10/791,777

Customer No.: 53080  
Confirmation No.: 4422

Filed: March 04, 2004

Group Art Unit: 2822

Examiner: Lewis, Monica

Title: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

**AMENDMENT UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated December 12, 2006, having a three-month shortened statutory period for response set to expire March 12, 2007, please amend the above-identified application as follows.